


Search Notes 	Application/Control No. 10549438	Applicant(s)/Patent Under Reexamination KUNZE ET AL.
	Examiner Wai-Sing Louie	Art Unit 2814

SEARCHED			
Class	Subclass	Date	Examiner
257	415,419,467,469	3/6/08	WSL
257	48	3/7/08	WSL
438	50,52	3/6/08	WSL

SEARCH NOTES		
Search Notes	Date	Examiner
MEMS, micro-electromechanical, group III nitride, silicon substrate, schottky contact	3/7/08	WSL

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner